

DO NOT ENTER: /G.G./ (02/26/2009)

ATTORNEY DOCKET NO:72096

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : TAKAMATSU
Serial No : 10/565,879
Confirm. No : 7943
Filed : January 23, 2006
For : WAFER POLISHING METHOD
Art Unit : 1792
Examiner : George A. Goudreau
Dated : February 18, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

In response to the Final rejection dated November 26, 2008, please amend the above identified application as follows:

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